CP3723



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Dvir, Eran; Finarov, Moshe; Haimovich, Eli; Shulman, Beniamin

Assignee:

Nova Measuring Instruments, Ltd.

Title:

Apparatus For Optical Inspection Of Wafers During Polishing

Serial No.:

09/498,926

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Examiner:

E. Morgan

Group Art Unit:

3723

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San Jose, California December 19, 2000

COMMISSIONER FOR PATENTS

Washington, D. C. 20231

INFORMATION DISCLOSURE STATEMENT UNDER CFR § 1.97(c) WITH FEE

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Dear Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, Applicants wish to call the following documents (copies enclosed) to the attention of the Examiner.

A PTO form 1449 listing these documents is enclosed.

Citation of the above documents shall not be construed as:

- 1. an admission that the documents are necessarily prior art with respect to the instant invention;
 - 2. a representation that a search has been made, or
- 3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

25 METRO DRIVE SUITE 700 SAN JOSE, CA 95110 (408) 453-9200 FAX (408) 453-7979 Please charge Deposit Account No. 19-2386 \$240.00 for the Information Disclosure

Statement fee under 37 C.F.R. § 1.17(p). The Commissioner is hereby authorized to charge
any additional fees which may be required, or credit any overpayment to Deposit Account 19
2386. This paper is being submitted in duplicate.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C.

20231, on <u>Dec. 19</u>, 2000.

Attorney for Applicants

12/19/00 Date of Signature Respectfully submitted,

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